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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	: 10/579,777	Confirmation No.	: 5716
First Named Inventor	: Hiraku ISHIKAWA		
Filed	: February 26, 3008		
TC/A.U.	: 1792		
Examiner	: Shamim Ahmed		
Docket No.	: 101994.57726US		
Customer No.	: 23911		
Title	: Plasma Film-Forming Apparatus and Plasma Film-Forming Method		

REPLY TO OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following remarks are respectfully submitted in response to the final Office Action dated April 21, 2009.

The **Listing of Claims** begins on page 2 of this paper.

Remarks begin on page 5 of this paper.